Attorney Docket Number | ARL 98-68D

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			U. S. PATENT	DOCUMENTS	
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ^{2 (f known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
1E	AA	^{US-} 5,465,475	11-14-1995	Kinoshita, et al.	
	AB	^{US-} 5,507,080	04-16-1996	Hayashi, et al.	
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages	
		Country Code ^{3 -} Number ^{4 -} Kind Code ⁶ (if known)	MM-DD-YYYY		Or Relevant Figures Appear	۲٥
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Examiner Signature	Timbly V. Eles	Date Considered 10/25/64

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Substitute for form 1449/PTO INFORMATION DISCLOSURE				Complete if Known		
				Application Number		
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STATEMENT BY APPLICANT		First Named Inventor	Meimei Z. Tidrow			
	•			Art Unit		
(Use as many sheets as necessary)			ecessary)	Examiner Name		
Sheet	2	of	2	Attorney Docket Number	ARL 98-68D	
Examiner	Cite		me of the author (i		of the article (when appropriate), title of	
Initials*	No.¹	the item (t		urnal, serial, symposium, ca), publisher, city and/or coun	talog, etc.), date, page(s), volume-issue try where published.	T ²
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Initials*	No.¹	the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
R	AF	A. GOYAL, et al. "Material Characteristics of Perovskite Manganese Oxide Thin Films for Biometric Applications, Applied Physics Letters 71, October 27, 1997, pgs 2535-2537	
TE	AG	Z. TRAJANOVIC, et al. "Growth of Colossal Magnetoresistance Thin Films on Silicon," Applied Physics Letters 69, August 12, 1998, pgs. 1005-1007	

Examiner	1. 11 1/11	Date	
Signature	Tunothy. Ulen	Considered	10/25/04

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